



IFW

501.43140X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: F. NAKAYAMA et al  
Application No.: 10/670,258  
Filed: September 26, 2003  
For: SEMICONDUCTOR DEVICE AND MANUFACTURING  
THE SAME  
Art Unit: 2891  
Examiner: B. SMITH

**AMENDMENT**

**MS: AMENDMENTS**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**July 19, 2005**

Sir:

In response to the Office Action dated April 19, 2005, please amend the above-identified application as listed below and as set forth on the following pages:

**Amendments to the Title;**

**Amendments to the Claims;**

**Remarks are included following the amendments and**

**AMENDMENTS TO THE TITLE**

Please amend the title to read as follows:

**SEMICONDUCTOR DEVICE AND MANUFACTURING THE SAME INCLUDING**  
**MULTIPLE WIRING LAYERS AND CIRCUITS OPERATING IN DIFFERENT**  
**FREQUENCY BANDS**